



PTO/SB/08a (08-03)

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 1 of 3

Complete if Known

Application Number	10/616,044
Filing Date	July 8, 2003
First Named Inventor	Yang, et al.
Art Unit	1753
Examiner Name	Nam X. Nguyen
Attorney Docket Number	AMAT/7669.P2/CMP/ECR/RKK

U.S. PATENT DOCUMENTS

Examiner Initials *	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
LV ↓ ↓ ↓ ↓ ↓ ↓ ↓ ↓ ↓ ↓ ↓ ↓ ↓ ↓ ↓ ↓ ↓ ↓	A1	2004/0016647 A1	01/29/2004	Yang, et al.	
	A2	20040118694 A1	06-24-2004	Yang et al.	
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	A4	5,656,386	08-12-1997	Scherer et al.	
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Examiner Initials *	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				
LV ↓ ↓ ↓ ↓ ↓ ↓	B1	11 186210	07/09/99	JP		
	B 2	11 162905	06/18/99	JP		
	B 3	10 242110	09/11/98	JP		
	B 4	10 177988	06/30/98	JP		
	B5	9 293658	11/11/97	JP		
	B6	7 14811	01/17/95	JP		
LV	B7	WO-98/27585	06/25/1998	IBM Corporation		

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/Luan Van/ (08/30/2006)

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**SUPPLEMENTAL
INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet 2 of 3

Complete if Known

Application Number	10/616,044
Filing Date	July 8, 2003
First Named Inventor	Yang, et al.
Art Unit	1753
Examiner Name	Nam X. Nguyen
Attorney Docket Number	AMAT/7669.P2/CMP/ECR/RKK

U.S. PATENT DOCUMENTS

Examiner Initials *	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
LV	A22	6,518,184	02/11/2003	Chambers, et al.	
	A23	6,270,635	08/07/2001	Woo	
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	A41	2004-0206628	10-21-2004	Lubomirsky et al.	
	A42	2004-0016637	01-29-2004	Yang et al.	
	A43	2004-0217005	01-14-2004	Yang et al.	
LV	A44	2004-0192086	01-30-2004	Lubomirsky et al.	

FOREIGN PATENT DOCUMENTS

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		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				

Examiner
Signature

/Luan Van/ (08/30/2006)

Date
Considered

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Substitute for form 1449B/PTO		Complete if Known	
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Application Number	10/616,044
		Filing Date	July 8, 2003
		First Named Inventor	Yang, et al.
		Art Unit	1753
		Examiner Name	Nam X. NGuyen
Sheet 3 of 3	Attorney Docket Number	AMAT/7669.P2/CMP/ECP/RKK	

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials *	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
LV	C1	Colombo; "Wafer Back Surface Film Removal," Central R&D, SGS-THOMSON Microelectronics, Agate Italy	
LV	C2	Pitney, "Ney Contact Manual" October 1974	
LV	C3	Semitool Product Catalog (on-line) October 27, 1998	
LV	C4	Singer, "Copper Has Enormous Benefits When Compared to Aluminum, but its Implementation Requires Some Fundamental Changes in Process Technologies," Semiconductor International June 1998.	
LV	C5	Singer, "Wafer Processing," Semiconductor International June 1998.	
LV	C6	PCT International Search Report from International Application No. PCT/US 2004/022183, dated October 15, 2004.	

Examiner Signature	/Luan Van/ (07/31/2006)	Date Considered	
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